## ARTICLE 34 AMENDMENTS

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## **AMENDMENT**

(amendment under the provision of Article 11)

To: The Commissioner of Patent Office Esq.

- 5 1. Indication of International Application: PCT/JP03/08989
  - 2. Applicant

name: NEC Corporation

address: 7-1, Shiba 5-chome, Minato-ku,

Tokyo 108-8001, JAPAN

10 nationality: JAPAN

residence: JAPAN

3. Attorney:

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name (6401): Patent Attorney: HAMADA Haruo

address: Wisdom House, 4-12, Minami-Aoyama 3-chome,

Minato-ku, Tokyo 107-0062, JAPAN

4. Object of the Amendment

claims

- 5. Contents of the Amendment
- (1) New claim 9 on page 55 of claims is added.
- 20 6. List of the Attachments

claims on pages 55

## **AMENDMENT**

a reaction chamber equipped with a substrate heating member capable of loading a substrate, and a shower head capable of spraying a mixed gas uniformly onto a surface of the substrate loaded on the substrate heating member;

an RF power supply connected to the shower head for supplying an RF voltage to the shower head, in respect to the earthed heating member; and

an evacuation apparatus for reducing a pressure in the reaction chamber,

wherein the plurality of monomer gas supplying units comprises at least a first monomer supplying unit for vaporizing and supplying a first organosiloxane with cyclosiloxane backbone, and a second monomer supplying unit for vaporizing and supplying a second organosiloxane with straight-chain siloxane backbone.

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- 8 A vapor deposition apparatus according to claim 7, further comprising a cleaning gas supplying unit, wherein the unit for mixing the plurality of monomer gases mixes a cleaning gas supplied from the cleaning gas supplying unit into the plurality of monomer gases.
  - 9. (Addition) The organosiloxane copolymer film according to claim 1 for forming the bridge structure by bonding in plural the first organosiloxane and the second organosiloxane via an organic group.

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